



IR-2314 (2-3588)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Eddy Ying Yin Ho et al.

Date: January 5, 2004

Serial No.: 10/625,958

Group Art Unit:

Filed: July 24, 2003

Examiner:

For: GLOBAL CLOSED LOOP CONTROL SYSTEM WITH DV/DT CONTROL AND  
EMI/SWITCHING LOSS REDUCTION

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of a search report issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Commissioner for Patents P.O. Box 1450,  
Alexandria, VA 22313-1450, on January 5, 2004  
Brendan J. Kennedy

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Name of applicant, assignee or  
Registered Representative

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*Brendan Kennedy*  
Signature

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January 5, 2004

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Date of Signature

Respectfully submitted,

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Enclosures

<b>APPLICANT'S ART CITATION</b> <small>(Use several sheets if necessary)</small>  <i>JAN 8 2004</i>	Application 10/625,958	OGFS File No. IR-2314 (2-3588)
	Applicant EDDY YING YIN HO ET AL.	
	Filing Date JULY 24, 2003	Group Art Unit

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-6,567,283 B2	05-2003	WELCHES			
	US-5,235,504	08-1993	SOOD			
	US-4,310,866	01-1982	WIRTH			
US-						
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US-						
US-						
US-						
US-						
US-						

**FOREIGN PATENT DOCUMENTS**

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

		International Search Report mailed 05 December 2003 for PCT/US03/23427

Examiner	Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.